

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masahiro FURUSAWA et al. Group Art Unit: 1762

Application No.: 10/028,712 Examiner: W. Markham

Filed: December 28, 2001 Docket No.: 111604

For: A METHOD FOR FABRICATING A SILICON THIN-FILM

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the November 18, 2003 Office Action, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims;

Amendments to the Drawings include an attached replacement sheet; and

Remarks.